

CUSTOMER SUPPORT NETWORK

BACKGROUND OF THE INVENTION

1. Field of the Invention

The present invention relates to the field of computer networking, and more particularly to a system and method for operating and maintaining equipment at a remote location using the Internet without placing ultimate control over the equipment in the hands of the remote user.

2. Brief Description of Related Developments

The fabrication of today's semiconductors requires complex tools for processing various stages of the wafer and inspecting the wafer at each stage or layer. During wafer processing, if the production equipment varies outside of desired control limits, the equipment can be subjected to defects that produce defective devices and a loss of yield. Because of the high cost associated with these problems, many types of defect inspection instruments are employed to screen the inspection devices and locate potential problems early in the process. These defect inspection systems enable early correction of potential problems. Defect inspection tools are themselves very sophisticated systems which measure, model and compare the results of inspections performed at each production step. These inspection systems also can develop problems, which impact their ability to monitor production and accurately detect and characterize defects.

In the last two decades, the semiconductor fabrication industry has developed systems for monitoring complex capital equipment to assure proper performance. Similar systems have been employed in the medical imaging industry where the quality of performance of the equipment has a direct impact on the ability of a radiologist, for example, to detect and diagnose pathology. As in any other type of imaging system, the overall performance is the result of many variables difficult to quantify from merely observing the end result. Manually measuring these variables (or critical performance parameters) requires a significant expenditure of time, which precludes frequent evaluation and correction or centralized (off site) calibration. The time required to perform these evaluations also impacts the overall productivity and effectiveness of the imaging system.

To solve the problem of continually manually monitoring the performance of the system while having the smallest impact possible on the productivity of the system, manufacturers have developed automated external monitors having the ability to periodically and regularly sample various relevant parameters. These equipment monitors sample various sources of information: data from sensors within the equipment, results of automated quality assurance tests, detailed diagnostic information, and reliability and utilization information gathered from equipment logs. The equipment monitors and/or associated equipment analyze this information and the status of the device is evaluated, reports developed, and any significant deviation from normal automatically reported to the service provider and the customer. Notification to

the service provider automatically opens a service case and initiates a series of follow-up actions to initially investigate the report, evaluate the data, diagnose the cause, and correct the problem or contact the customer to
5 schedule a time to effect the repair.

The character of the semiconductor industry is such that competition requires that products be designed, manufactured, and marketed in the most efficient and cost
10 effective manner possible. To achieve this end, improvements in fabrication technology have had to keep pace with the rapid improvements in the electronics industry. As such, the performance of machines in fabrication facilities must be regularly monitored to
15 ensure that they operate as efficiently as possible.

As used herein, the term "customer" refers to a purchaser and/or user of an inspection tool or inspection tool monitoring device. A customer employs the inspection
20 tool or inspection tool monitoring device to evaluate the quality of a semiconductor device, and may sell, integrate, or otherwise pass along the semiconductor device. An "inspection tool" or "production equipment" refers to the device used to inspect the semiconductor
25 device, while an "inspection tool monitoring device" or "defect inspection instrument" refers to a device used to evaluate certain parameters or the performance of an inspection tool.

30 The standard approach to diagnosing equipment problems involves servicing equipment only when a problem is reported by a customer. When such a problem is reported, a service engineer is typically sent to the

customer site and, after arriving at the site, collects inspection tool and/or inspection tool monitoring device data in an attempt to diagnose the problem. This approach results in significant equipment downtime and requires a
5 great deal of time, effort, and cost associated with the service engineer.

This conventional, highly subjective method of manually evaluating and calibrating equipment results in
10 greatly varied results. For example, results and down times can vary widely from one service engineer to another, and can produce a significantly increased repair time. Moreover, the standard approach of servicing a piece of equipment only when a problem is reported by a
15 customer results in increased downtimes and lost revenue for both the customer and the service organization.

As may be appreciated, use of an automated device to monitor performance of inspection tools and inspection
20 tool monitoring devices may subject the tool data, settings, or other related information to capture by third parties. Data networks trafficking in this sensitive data, such as the internet, may employ commonly available encryption methods such as SSL and firewalls,
25 but customers in the rapidly changing semiconductor fabrication industry tend to be extremely reticent to expose data to such data networks unless a scheme can be devised that offers an exceedingly high level of security.

SUMMARY OF THE INVENTION

The present invention is directed in one aspect to a system for accessing data remotely from a network. In one embodiment, the system comprises a first network interface card permitting data transfer between a local network and an intermediate network; a second network interface card permitting data transfer between intermediate network and a remote network; and a module located within the intermediate network, through which all data transferring between the first network and the third network must pass. Information transmitted by the remote network may or may not be received and acted upon by the local network depending on a set of predetermined criteria applied by the intermediate network.

In another aspect, the present invention is directed to a system for accessing a local network from a remote network through an intermediate network. In one embodiment the system comprises a first network interface card permitting data transfer between the local network and the intermediate network; a second network interface card permitting data transfer between the remote network and the intermediate network; a module located within the intermediate network, through which all data transferring between the local network and the remote network must pass; and an equipment diagnostic monitor system located within the intermediate network, wherein the equipment diagnostic monitor system monitors tests performed on at least one item residing within the local network.

In a further aspect, the present invention is directed to a data system. In one embodiment the data network

comprises a first network interface device enabling data transfer between a local network and an intermediate network; a second network interface device enabling data transfer between a remote network and the intermediate network; and an equipment diagnostic monitor system located within the intermediate network, wherein the equipment diagnostic monitor system monitors tests performed on at least one item in the local network.

BRIEF DESCRIPTION OF THE DRAWINGS

The foregoing aspects and other features of the present invention are explained in the following description, taken in connection with the accompanying drawings, wherein:

FIG. 1 is a block diagram of one embodiment of a system incorporating features of the present invention.

FIG. 2 illustrates the functional interface between a first remote network containing tool monitoring equipment, a second intermediate network containing an equipment diagnostic monitor system, and a third remote network containing remote control equipment according to an embodiment of the present invention.

FIG. 3 illustrates the login process by a user on a remote network into a central server and an equipment diagnostic monitor system on the second network according to an embodiment of the present invention.

FIG. 4 illustrates the processing that occurs where

a user on the remote network successfully logs into the equipment diagnostic monitor server according to an embodiment of the present invention.

5 FIG. 5 illustrates the current tool server architecture according to an embodiment of the present invention.

10 FIG. 6 illustrates a general overview of the equipment diagnostic monitor system function interface, specifically highlighting the remote control viewing process according to an embodiment of the present invention.

15 FIG. 7 illustrates the equipment diagnostic monitor system client architecture, and illustrates how a remote user can access the database according to an embodiment of the present invention.

20 FIG. 8 shows the architecture of the equipment diagnostic monitor's system Queue Manager (QMGR) according to an embodiment of the present invention.

25 FIG. 9 shows the layout of the equipment diagnostic monitor system database according to an embodiment of the present invention.

DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENT(S)

30 Referring to Fig. 1, there is shown an exploded perspective view of a system 10 incorporating features of the present invention. Although the present invention will be described with reference to the embodiment shown

in the drawings, it should be understood that the present invention can be embodied in many alternate forms of embodiments. In addition, any suitable size, shape or type of elements or materials could be used.

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Referring to FIG. 1, the present invention generally comprises a system 10 for providing remote access to one or more device 62, also referred to herein as a tool. In one embodiment, the tool 62 comprises a semiconductor manufacturing or inspection tool. The system 10 generally comprises a local network 70 having access to the tool 62, an intermediate network 72 including an equipment diagnostic monitoring system 74, and remote network 76 that provides a user remote access to the tool 62. In alternate embodiments, the system 10 can include such other suitable components or networks to allow the diagnosis or analysis of the tool 62 from a remote facility. It is a feature of the present invention to provide a system that allows a user to access a tool from a remote facility in a secure manner so that all communications related to the tool are not able to be intercepted by unauthorized parties.

As shown in FIG. 1, the local or first network 70 is adapted to communicate to the intermediate or second network 72 over a communication interface or channel 76. In one embodiment the communication interface 76 network interface card. In alternate embodiments, the first and second networks 70, 72 can communicate via any suitable communication system, network or device. The second network 72 and remote network 76 are adapted to communicate with each other via a second communication interface 80. In one embodiment, the second

communication interface or channel 80 comprises a second network interface card.

The intermediate network 72 is generally adapted to allow users 90, via the remote network 76, to access, correct and alert based on the desires or needs of the tool 70 and tool owner.

The remote network 76 is generally adapted to allow a user 90 to access the remote network 76 over a communication network, such as for example the Internet (world wide web).

As shown in FIG. 1, the second or intermediate network 72 includes an equipment diagnostic monitoring system 74, also referred to herein as "equipment diagnostic monitor" that is generally adapted to monitor and analyze the tool 62. The equipment diagnostic monitoring system 74 can also be adapted to provide alerts based on the tool status. The system 10 allows a remote user to request information about a tool 62, and provide suggested input to the tool 62. This input can include for example, calibration values, tool data or other information. The requests or commands can be accepted or rejected by the system 10 based on a predetermined set of criteria maintained by the dual network interface card arrangement and the intermediate network 72, including the equipment diagnostic monitoring system 74.

FIG. 2 illustrates one embodiment of a system 10 incorporating features of the present invention. As shown in FIG. 2, the system 10 can generally comprise a

first network 100 containing tool monitoring equipment 105, 175, a second network 110 containing an equipment diagnostic monitor system 120, and a remote network 150 containing remote control equipment. The first network 100 could be located for example at a fabrication factory 104 at a customer's site where semiconductor wafers or chips, for example, are manufactured. As used herein, the term "customer" refers to a purchaser and/or user of an inspection tool 102 or inspection tool monitoring device. Tooling software 105 runs on the first network 100. The tooling software 105 is generally adapted to perform tests such as diagnostic or performance tests, on the tool 102. These tests are run to evaluate the tool's performance and can be used to determine whether the tool 102 is functioning properly or should be recalibrated, for example. The first network 100 may communicate with a second network 110 via a first network interface card (NIC #1) 115. After a test is run, the performance data is transmitted to the test to the equipment diagnostic monitor system ("iDM") 120 for evaluation and storage.

The equipment diagnostic monitor system 120, which is shown located in the second network 110, has numerous functions, including controlling the tests performed by the tool software 105, saving data from the tooling tests, analyzing data from the tests, and sending out alerts to concerned personnel when errors with the tool 102 on tool performance are discovered. The equipment diagnostic monitor system 120 architecture generally employs various operative and functional modules. The constituent equipment diagnostic monitor system 120 modules can include a monitoring submodule 125, an analysis submodule 130, an alerts submodule 135 and an

active transfers (active Xfers) submodule 140. In alternate embodiments, the equipment diagnostic monitor system 120 can include such other suitable devices or components for remote monitoring and analysis of a semiconductor manufacturing tool. It is a feature of the present invention to diagnosis and analyze the performance of a semiconductor manufacturing tool from a remote facility.

The equipment diagnostic monitor system 120 oversees the tooling tests and controls the flow of data to and from the tool 102. While a test is being run by the tool software 105, the data from that particular test is generally not accessible to the equipment diagnostic monitor system 120. However, after a test is completed, the data can be accessed by the equipment diagnostic monitor system 120, which receives the data and analyzes it in the analysis submodule 130. The equipment diagnostic monitor system 120 then sends the data via an OCI [PLEASE DEFINE TERM] 146 to a database 145. During the analysis, if any irregularities with the tool 102 or any predetermined thresholds or other criteria are detected, an alert may be sent to a remote user via the remote network 150. This alert is sent by the alerts submodule 135 and may be in any suitable form, such as for example, a fax, page, email, or any other form of communication to appropriate personnel or locations. After the tool software 105 performs a test, the test data is sent to the equipment diagnostic monitor system 120, which, after analyzing the data, passes the test data into the database 145. The database 145 can comprise any suitable medium for the storage of data, such as for example, an Oracle™ or KLA™ database.

The equipment diagnostic monitor system 120 may be comprised of general computing hardware such as for example, a Pentium 200 MHz (with 64 MB RAM, 3.2 GB Hard disk drive (HDD)) or above computer system; two standard 10/100 Ethernet adapters; and Fax/modem cards (for paging and faxing). In alternate embodiments, any suitable computing hardware arrangements capable of providing the functionality described herein are also acceptable. In one embodiment, examples of the software of the equipment diagnostic monitor system 120 can include Windows NT™ Server 4.0 and above; Microsoft Internet Information Server (Web Server); Microsoft MS Access (database); Microsoft Proxy Server; Allaire ColdFusion; and certain applicable third party tools/SDK (e.g., faxing, paging, image analysis, statistical analysis, expert system, etc.). In alternate embodiments, any suitable software or systems that are capable of providing the functionality of the various embodiments of the present invention described herein can be used or incorporated.

The second network 110, in which the equipment diagnostic monitor system 120 generally resides, is accessible from a remote network 150 through a second network interface card (NIC #2) 155. The second network 110 is accessible through the second network interface card 155 from a Central Support Application 165. In one embodiment this can include for example, a java applet running when the IP address for the second network 110 is accessed via a network browser 160 such as for example, a World Wide Web (WWW) browser. When a user at the remote location 108 has the proper passwords and authorizations, he may indirectly access a remote control desktop 175 at

a tool 102 located on the first network 100 from a remote control viewer 170. However, the user cannot directly access the tool 102 from the remote control viewer 170 because the user must go through the second network 110.

5 A remote control (RC) proxy server 180 can lie between the remote control viewer 170 on the remote network 150 and the remote control desktop 175 on the first network 100. The RC proxy 180 is generally adapted to prevent direct IP routing and hides the IP address of the remote
10 control desktop from a user on the remote network 150. In alternate embodiments any suitable device can be used to connect the remote control viewer 170 to the remote control desktop 175. It is a feature of the present invention to allow a user to access a tool from a remote
15 network through a separate network to prevent direct IP routing to the tool and keep communications secure. The RC proxy 180 generally comprises a device or software that prevents direct IP routing for security purposes.

20 Also located on the second network is a MS IIS 185, which generally comprises a Microsoft web server operating on for example, a Microsoft NT machine and enabling communication with the remote network 150. A MS proxy 190 can also be included in the system 10 that is
25 generally adapted to provide an interface proxy between the remote network 150 and the equipment diagnostic monitor system 120, with the MS proxy 190 located on the second network.

30 FIG. 3 illustrates one embodiment of a login process according to features of the present invention. Referring to FIGS. 2 and 3, in order for a user on a desktop 200 at the remote network 150 to access the equipment diagnostic

monitor system 120, the user must first login to an ACE™ server 205. If the user has the correct ACE™ token card, login and password, the user may log 4 into the ACE server 205 and then access 6 a central server 210.

5 Multiple equipment diagnostic monitoring systems 120 are accessible through the central server 210. If the user does not have the correct token card or password, the login fails 8. On a successful login to the ace server 205, the user connects 10 to the central server 210 and an applet is sent 12 from the central server to the desktop 200 located on the remote network 150. After a user on the desktop 200 types in a login and password, this information is sent 14 to the central server 210. Upon a successful login, the user may select 18 a specific equipment diagnostic monitor system 120 to access. After the user has selected an equipment diagnostic monitor system 120, a browser program is launched 20 on the desktop 200. The equipment diagnostic monitor system 120 then sends 22 an applet to the desktop 200 for login. After the user enters this login information, the equipment diagnostic monitor system 120 processes 24 the login. If successful, the user at the desktop 200 may make requests 26 for data from particular tools 102.

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30 FIG. 4 illustrates the processing that occurs where a user at the desktop 200 successfully logs into the equipment diagnostic monitor system server 122 according to an embodiment of the present invention. After successfully logging in to the equipment diagnostic monitor system 120, the user may access the tool 102. A request 300 for remote control is first sent to the equipment diagnostic monitor system 120. Next, an

authentication dialog box can be displayed 305 on the tool 102. Then, the username and password are sent 310 from the tool 102 to the equipment diagnostic monitor system 120. Upon a successful authentication, a command 5 315 is sent to the tool 102 from the equipment diagnostic monitor system 120 instructing the tool 102 to begin a remote session. The remote session is started 320 at the tool 102. Only one port in the specified range is generally used for communication at any time. When a 10 remote session is authenticated, a message is sent 325 to the desktop 200 to inform the user of this occurrence. If the authentication fails, an error message is sent 330 to the desktop 200 where it is displayed.

15 Requests from a user are generally classified as passive or active. A passive request does not interact with the host tool 102 in any way. However, an active request initiates some action on the host tool 102. Passive requests are used for either configuring the site 20 or for analyzing the data present in the local database 145 shown in FIG. 2. Passive requests run with more security privileges than active ones. User access to the request is determined by static privileges and dynamic privileges. These privileges are stored in the database 25 145 and are accessible by the equipment diagnostic monitor system 120. The customer determines these static components when the equipment diagnostic monitor system 120 software is installed. For example, a customer may limit access to and the ability to alter tool settings 30 solely to company technicians. This static component determination involves examining the appropriate registry entries. The dynamic privilege depends upon the host status at the time of the request. For example, when the

network traffic crosses a preset threshold, only passive requests may be allowed. In other words, dynamic privileges are system dependent and may be granted in certain circumstances and denied in others, again as
5 determined at least in part by the customer.

Passive requests are allowed even when the host tool 102 is in critical operation. To submit an active request, a user must have active request privileges and
10 be logged in to the equipment diagnostic monitor system 120 to which the tool 102 he wants to analyze is connected. If the user has access to the correct equipment diagnostic monitor system 120, the next step is to verify whether the tool 102 is controlled by the
15 equipment diagnostic monitor system 120 in question, and whether the user has privileges to access that particular tool 102. If the user has access to that tool 102, he may request that an active test be run. The remote user may also submit a recalibration suggestion to an operator of
20 the tool 102.

Each tool 102 can have a display on which a suggestion sent from a remote user can be displayed. For example, where a technical engineer decides that a tool
25 102 should be recalibrated, he may send a recalibration message to the tool 102. Where the user has the privilege of sending a suggestion to the display on the tool 102, the suggestion is displayed. An operator of the tool 102 may choose whether to follow or disregard such a
30 suggestion. This setup prevents a remote user from changing the settings on a tool at an inopportune time, or changing settings without anyone knowing about it.

FIG. 5 illustrates the tool server architecture according to an embodiment of the present invention. The tool 502 and the equipment diagnostic monitor system 520 communicate via a number of interfaces on the first network interface card 515. The tool 502 may communicate through a DCOM interface 400 with a DCOM interface 402 at the equipment diagnostic monitor system 520. Alternatively, the tool 502 may communicate through a CORBA interface 404 with a CORBA interface 406 at the equipment diagnostic monitor system 120. In alternate embodiment the tool 502 and equipment diagnostic monitor system 520 can communicate through any suitable architecture or communication interface. A number of modules may operate at the tool 502 at a time. In the DCOM 400 architecture, the modules may include an NT Tools module 408, a Microsoft Message Queue (MSMQ) Client 410, an Active Request module 412, an equipment diagnostic monitor system query message sender (IQMS) module 414, and an E10 Object 416. This architecture runs under the Windows NT™ platform. The active request module 412 has the function of receiving an active request from a user. When a remote user submits an active request, the active request module has the function of following the request. The IQMS 414 has the function of sending the resultant data from the active request to the equipment diagnostic monitor server 120.

Referring to FIG. 5, in the CORBA interface 404, 406, the modules at the tool 502 may include modules such as an active request module 418, a UNIX tools module 420, an equipment diagnostic monitor system data sender module 422, and an E10 Object module 424. This architecture can run under the UNIX operating system. The equipment

diagnostic monitor system data sender (IDS) module 422 sends data from tests to the equipment diagnostic monitor system 120. The active request module 418 has the function of receiving an active request from a user. When
5 a remote user submits an active request, the active request module has the function of following the request.

A number of modules also are located within the equipment diagnostic monitor system 520. For the DCOM
10 interface 402 side of the equipment diagnostic monitor system 520, there are several modules. There is an equipment diagnostic monitor system manager module 426 which has the function of managing the operation of the equipment diagnostic monitor system 520. A network
15 monitoring/service components module 428 monitors the network in which the equipment diagnostic monitor system 520 resides. The MSMQ server 430 receives and queues messages sent from the tool 502. Further, there is an equipment diagnostic monitor system query message
20 receiver (IQMR) 434, which has the function of receiving data sent from the IQMS 414. A data logging module 436 provides data logging capability and is also on the DCOM 402 side of the equipment diagnostic monitor system 520 server.

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The CORBA interface 406 side of the equipment diagnostic monitor system 520 also includes certain components. An equipment diagnostic monitor system data receiver (IDR) module 432 receives data from the IDS
30 module 422. An XML parsing engine 438 converts the raw data from tests at the tool into data which can be analyzed by the equipment diagnostic monitor system 520.

As shown in FIG. 4, the modules running under both the DCOM interface 402 and those under the CORBA interface 406 both interact with other modules in the equipment diagnostic monitor system 520. These other modules include a database (DB) engine 440, with has the function of managing the flow of information between the equipment diagnostic monitor system 520 and the database 545 located external to the equipment diagnostic monitor system 520. The database 545 communicates with the database engine 440 through an OCI module 546.

FIG. 6 illustrates a general overview of an equipment diagnostic monitor system 680 function interface, specifically highlighting the remote control viewing process according to an embodiment of the present invention. As shown in FIG. 6, a user at a web browser 160 may log 162 into the central server 210. If the user supplies a correct login and password, the user may be connected to the Central server 210 and may have access to any of a number of equipment diagnostic monitor's system 680 managed by the central server 210. To access an equipment diagnostic monitor system 680, the user must know the name of the equipment diagnostic monitor system 680 and enter it. Then, the central server 210 allows the user to access the requested equipment diagnostic monitor system 680. At the selected equipment diagnostic monitor system 680, the user must supply 164 a correct login and password. Once logged in, the user may enter active 166 or passive 166 requests. These requests are allowed only if the user has the requisite privileges. In other words, the user must have the authorization to make such requests. Once logged in, the user's privileges may be uploaded from a file stored in a database such as

database 145 of FIG. 7. The user may also request 182 a remote viewing session. A remote viewing request is only allowed if the user has a remote viewing privilege. If the user has the correct privileges, he may make monitoring requests 172 and active requests 174 of data from the tool 692, and may also send messages with suggestions to a user at the tool 692. The user at the tool 692 may choose to either follow or disregard the suggestions.

FIG. 7 illustrates the equipment diagnostic monitor system 720 client architecture, and illustrates how a remote user may access the database 645 according to an embodiment of the present invention. First, the user must access the web server 600 at the equipment diagnostic monitor system 720 from an Internet web browser 160. Although this embodiment of the present invention is described in terms of the web, it should be understood that the features of the present invention can be embodied in any suitable communication network. The web server 600 may run for example, under the Windows NT operating system. The web server 600 sends 650 an applet 604 to the browser 160. With the applet 604, the user may access the database (DB) server 605. The DB server 605 has the function of accessing data from the database and providing it to the user as requested. The user must log in 654 to the DB server 605. Once logged in, the user may make requests through the RMI Interfaces 610. The RMI Interfaces 610 are provide for interfacing between the user and the DB server 605, particularly the login requests made by the user. The requests may be active or passive. The DB server 605 may also sent out notifications 615 when errors are detected. Finally, the

DB server 605 has a summarization module 620, which analyzes data collected from the tool 672.

5 The DB server 605 communicates with a database 645, such as for example, the Oracle™ database 645 using structured query language (SQL) 625. The database 645 operates in UNIX and has a function of storing user privileges and all data from tests performed on the tool 672.

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The monitoring process can be divided into three categories: (1) performance monitoring, (2) reliability monitoring, and (3) physical parameter monitoring. Performance monitoring deals with viewing of images, and
15 acquiring and analyzing performance data.

Reliability monitoring includes acquiring and analyzing the various logs available on a system. For example, in order to view any of the error log tables, a request is made. If the request is authenticated, the
20 user can view that particular error log table. The error log table presents errors for a particular tool, such as computational errors, calibration errors, general system faults, and so forth. The data is shown in the form of a
25 table, histograms and profile charts. Physical parameter monitoring includes evaluating the physical parameters for various system hosts.

FIG. 8 shows the architecture of the equipment
30 diagnostic monitor's system Queue Manager (QMGR) according to an embodiment of the present invention. The tool software 755, which runs at the tool 702, communicates with the equipment diagnostic monitor's

system Queue Manager Sender (EQMS) module 710 via COM
interfaces 705. The EQMS 710 sends a message via a
Microsoft Message Queue (MSMQ) 715 to a message
repository, such as a MSMQ server 724. The message
5 repository may be part of the Windows NT system or a part
of the equipment diagnostic monitor system 732.

The MSMQ server 724 may send a message to a MSMQ 725
located at the equipment diagnostic monitor's system 120
10 network. The MSMQ 725 may send a message to the equipment
diagnostic monitor's system queue manager receiver (EQMR)
730. The EQMR 730 has the function of receiving queued
messages from the MSMQ 725. The EQMR 730 may communicate
via a COM interface 735 with the equipment diagnostic
15 monitor system 120 DCOM client. The equipment diagnostic
monitor system 732 may communicate with an Oracle™
database 745 via the OCI 146.

FIG. 9 shows the layout of the equipment diagnostic
20 monitor system database 875 according to an embodiment of
the present invention. Configuration data 800 and data
805 collected from tools is stored in the database 875.
The configuration data is comprised of information 810
concerning the equipment diagnostic monitor system 120
25 and of information 815 concerning the tool 102 shown in
FIG. 2. The equipment diagnostic monitor system
information 810 may be comprised of information
concerning users and privileges 820, network information
825, and security information 830. The tool information
30 815 may be comprised of information 835 concerning tool
types and serial numbers as well as log file information
840.

The data 805 collected from the tool 102 may be comprised of raw tool data 845, common and interpreted data 850, and tool-specific data 855. Raw tool data 845 is data collected directly from tests on the tool 102.

5 Common and interpreted data 850 is comprised of summary tables of data collected from a plurality of tools 102. Tool specific data 855 is comprised of data such as the settings for a particular tool.

10 The present invention generally provides a more efficient system of equipment support and maintenance as well as early identification and assessment of a potential problem such that the problem can be quickly and efficiently addressed.

15 It should be understood that the foregoing description is only illustrative of the invention. Various alternatives and modifications can be devised by those skilled in the art without departing from the invention.

20 Accordingly, the present invention is intended to embrace all such alternatives, modifications and variances which fall within the scope of the appended claims.